## Status of the Claims

The listing of claims will replace all prior versions, and listings of claims in the application.

1. (Original) A method of sequentially exposing a field with an image of first and second reticles comprising:

simultaneously holding the first and second reticles and a calibration reticle on a reticle stage;

positioning the field in an exposure position; scanning an image from the first reticle to expose the field; repositioning the field to the exposure position; and scanning an image from the second reticle to expose the field.

- 2. (Original) The method of claim 1, further comprising: detecting an image of the calibration reticle; and calibrating the system based on the detecting.
- 3. (Original) The method of claim 2, further comprising performing the calibrating in real time.
- 4. (Original) The method of claim 1, further comprising:
  adjusting an exposure parameter between exposing the first and second reticles.
  - 5. (Currently Amended) The method of elaim 1 claim 4, wherein: the exposure parameter comprises exposure dose.
  - 6. (Currently Amended) The method of elaim 1 claim 4, wherein: the exposure parameter comprises partial coherence.

7. (Currently Amended) The method of claim 1, further comprising: using a phase shift reticles reticle as the first reticle; and using a trim reticle as the second reticle.